



Inventor: Brent A. McClure et al

Title: Capacitor Constructions and Methods of Forming

Assignee: Micron Technology, Inc.

Docket No.: MI22-2067

INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

The citations listed, copies attached, may be material to the examination of the subject application and are therefore submitted in compliance with the duty of disclosure defined in 37 CFR § 1.56. The Examiner is requested to make these citations of official record in this application. No admission is made regarding whether all the submitted references are prior art.

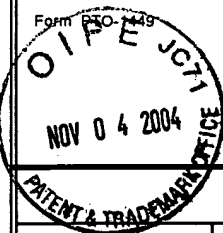
This Information Disclosure Statement is being filed before the mailing of a first Office Action on the merits. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this information disclosure statement, please charge the fee specified under 37 C.F.R. §1.17(p) to Deposit Account No. 23-0925. Please credit Deposit Account No. 23-0925 with any overpayment of the above fee.

Respectfully submitted,

Dated: 04 Nov 2004

Attorney: James E. Lake

James E. Lake
Reg. No. 44,854

Form PTO-449 		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-2067		SERIAL NO. 10/624,340	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Brent A. McClure et al			
				FILING DATE July 21, 2003		GROUP 2831	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,222,722	04/1999	Fukuzumi et al			
	AB	6,204,070	03/2001	Kim			
	AC	6,207,487	03/2001	Kim et al			
	AD	6,391,803	05/2002	Kim et al			
	AE	6,420,230	07/2002	Derderian			
	AF	6,281,543	08/2001	Al-Shareef et al			
	AG	5,452,178	09/1995	Emesh et al			
	AH	6,458,416	10/2002	Derderian et al			
	AI	6,309,923	10/2001	Tseng, Horng-Huei			
	AJ	6,270,572	08/2001	Kim et al			
	AK	6,551,399	04/2003	Sneh et al			
	AL	6,780,704	08/2004	Raaijmakers			
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AM	KR 2002002157A	01/2002	Korea			
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
AR							
AS							
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							